



RECEIVED

MAY 23 2005

TC 1700

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent of:

Hirayama et al

U.S. Patent No.: 6,884,365

Issue Date: April 26, 2005

For: GAS FOR PLASMA REACTION AND METHOD FOR PRODUCTION THEREOF

**SUBMISSION OF PUBLICATIONS UNDER 37 CFR § 1.501**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

May 17, 2005

Sir:

The undersigned herewith submits in the above-identified patent the following documents (including copies and English language abstracts thereof) which may be relevant to the patent:

<u>Document No.</u>	<u>By</u>	<u>Date</u>
EP 0913380	Nippon Zeon Co.	5/6/99
PCT WO98/19331	Nippon Zeon Co.	5/7/98
Supplemental EP Search Report		5/15/03

The documents are being submitted to be placed in the file wrapper of the subject patent.

U.S. Patent No.: 6,884,365

If any fees are necessitated by this submission, such may be charged to Deposit  
Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP



Donald W. Hanson  
Attorney for Applicants  
Reg. No. 27,133

Atty. Docket No. 011575  
Suite 1000, 1725 K Street, N.W.  
Washington, D.C. 20006  
(202) 659-2930  
DWH/nk



23850

PATENT TRADEMARK OFFICE

Enclosures: 2 publications and search report